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Attorney's Docket No. 5308-168

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Das et al. Confirmation No.: 2584
Serial No.: 09/878,442 Group Art Unit: 2815
Filed: June 11, 2001 Examiner: J. Jackson, Jr.
For: HIGH VOLTAGE, HIGH TEMPERATURE CAPACITOR STRUCTURES
AND METHODS OF FABRICATING SAME

Date: November 5, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
FOR INTERNATIONAL SEARCH REPORT**

Sir:

Attached is a Supplemental Form PTO-1449 listing documents cited in the International Search Report for the corresponding International Application Number PCT/US02/09393. Each document listed on the attached PTO-1449 was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of each document, including the Search Report, is enclosed. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.56 and MPEP § 609.

No fee is believed due; however, the Commissioner is hereby authorized to charge any deficiency or credit any refund to Deposit Account No. 50-0220.

Respectfully submitted,

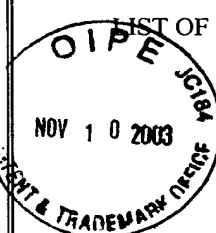
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 5, 2003.

Traci A. Brown

FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office				Attorney Docket Number 5308-168		Serial No. 09/878,442	
<div style="display: flex; align-items: center;"> <div style="text-align: center; margin-right: 10px;">  </div> <div> <p>LIST OF DOCUMENTS CITED BY APPLICANT</p> <p>(Use several sheets if necessary)</p> </div> </div>				Applicants: Das et al.			
				Filing Date: June 11, 2001		Group 2815	
U. S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	1	5,877,045	3/2/99	Kapoor	438	151	
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation Yes No
	2	WO99/63591	12/9/99	PCT			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	3	International Search Report for PCT/US02/09393 dated 10/15/03.					
	4	Mutin, P. Herbert, "Control of the Composition and Structure of Silicon Oxycarbide and Oxynitride Glasses Derived from Polysiloxane Precursors," <i>Journal of Sol-Gel Science and Technology</i> . Vol. 14 (1999) pp. 27-38.					
	5	del Prado et al. "Full Composition Range Silicon Oxynitride Films Deposited by ECR-PECVD at Room Temperatures," <i>Thin Solid Films</i> . Vol. 343-344 (1999) p. 437-440.					

 EXAMINER _____
 *EXAMINER

DATE CONSIDERED

Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.